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Attorney Docket No.: NECW 18.281

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors : Toru TATSUMI, *et al.*
Filed : Concurrently Herewith
Title : METHOD OF VAPOR PHASE GROWTH OF METAL
OXIDE DIELECTRIC FILM AND APPARATUS FOR
VAPOR PHASE GROWTH OF METAL OXIDE
DIELECTRIC MATERIAL

January 29, 2001

Assistant Commissioner for Patents
Box PCT
Washington, D.C. 20231

PRELIMINARY AMENDMENT

SIR:

Prior to the issuance of an Office Action, amend the claims as follows:

IN THE CLAIMS

Please delete claims 1-46 and substitute therefore claims 47-117 attached hereto.

REMARKS

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Respectfully submitted,

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